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Substitute for form 1449A/PTO

1 of 3

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Application Number	10/553,470		
Filing Date	May 19, 2006		
First Named Inventor	Raif LERNER		
Art Unit	2812 Unassigned / Andres Lopez Esquerra/		
Examiner Name			
Attorney Docket Number	60201 000041		

'Examiner Indials	Cite No.	DOCUMENT NUMBER Number - Kind Code (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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Substitute for form 1449/PTO					Application Number		10/553,470				
				CUDE	Fil	ling Date	May 19, 2006				
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)						First Named Inventor Art Unit Examiner Name		Raif LERNER			
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Sheet		20	f 3			Attorney Docket Number		60291.000041			
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EXAMINER SIGNATURE /Andres Lopez Esquerra			a/ :	DATE CONSIDERED	05/24/2007						
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				First Named Inventor	Raff LERNER						
				Art Unit	2812						
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Sheet		3 of 3		Attorney Docket Number	60291.000041						
	OTHER DOCUMENTS - NON-PATENT LITERATURE DOCUMENTS										
*Exeminer	Cite	Inclu	ude name of the author (in CAPITAL I	LETTERS), title of the article (when an	ppropriate), title of the	TRANSL	LATION				
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